

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 113.002.D1)

In the Application of: **YE ET AL.**) Group Art Unit:
Serial No: **DIVISIONAL OF 10/390,806**)) Examiner:
Filed: **AUGUST 22, 2003**))
Title: **SYSTEM AND METHOD FOR LITHOGRAPHY**)
 PROCESS MONITORING AND CONTROL))

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: